

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

LIOU et al.

Serial No.: 09/467,675

Filed: Dec. 21, 1999

For: Structure For ESD Protection With Single
Crystal Silicon Sided Junction

Examiner: NADAV, O

Art Unit: 2811

Docket No.: 252103-4540

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on December 6, 2001.


Signature - Hui Chin Barnhill

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JUN 25 2002

TECHNOLOGY CENTER 2800

RESPONSE TO OFFICE ACTION

Assistant Commissioner of Patents and Trademarks
Washington, DC 20231

Sir:

The Office Action mailed Aug. 13, 2001 (Paper No. 9), has been carefully considered. In response thereto, please consider the following remarks.

REMARKS**Present Status of the Application**

The Office Action rejected all presently-pending claims 1-16 and 18-21. Specifically, the Office Action rejected claims 1-16 and 18-21 under 35 U.S.C. 103(a), as being unpatentable over Yamaguchi et al. (U.S. Patent 6,118,154) in view of Hu et al. (U.S. Patent 6,121,077), Erdeljac et